Attorney's Docket No.: 10417-039001 / F51-125462M/HW



UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Toshimitsu Taniguchi et al.

Art Unit : 2811

Serial No.: 09/652,044

Examiner: Samuel A. Gebremariam

Filed

: August 31, 2000

Title

: SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

## AMENDMENT IN REPLY TO ACTION OF JULY 30, 2003

Please amend the above-identified application as follows:

## CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Date of Dep

Signature

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